

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Paul et al.

**Application No. 10/803,502** 

Filed: March 17, 2004 Confirmation No. 5691

METHOD FOR MAKING DEVICES For:

HAVING INTERMETALLIC

STRUCTURES AND INTERMETALLIC

**DEVICES MADE THEREBY** 

Examiner: Unknown

Art Unit: 3729

Attorney Reference No. 245-68071-01

COMMISSIONER FOR PATENTS

P.O. BOX 1450

**ALEXANDRIA, VA 22313-1450** 

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Attorney for Applicant(s)

Date Mailed

## TRANSMITTAL LETTER

Enclosed for filing in the application referenced above are the following:

- $\boxtimes$ Information Disclosure Statement Form 1449 and references cited thereon
- $\boxtimes$ The Director is hereby authorized to charge any additional fees that may be required, or credit over-payment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- $\boxtimes$ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

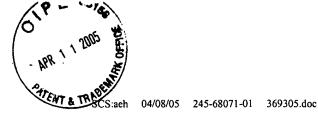
KLARQUIST SPARKMAN, LLP

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Portland, Oregon 97204 Telephone: (503) 226-7391 Facsimile: (503) 228-9446

cc: Docketing

No. 36.011



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Attorney for Applicant

Date Mailed

April 8, 2005

# INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. § 1.97(b)(3)

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

Listed on the accompanying form PTO-1449 and enclosed herewith are several English-language documents. Applicants respectfully request that these documents be listed as references cited on the issued patent.

Copies of United States patents and United States published patent applications do not have to be provided to the Patent Office (37 C.F.R. 1.98(a)(2)(ii)). Copies of unpublished U.S. applications do not have to be provided, as long as the application is available on PAIR, as this requirement of 37 C.F.R. § 1.98(a)(2)(iii) has been waived by the United States Patent and Trademark Office pursuant to the Official Gazette Notice on October 19, 2004 (1287 OG 163). Applicants will provide copies of such patents or applications upon request.

**PATENT** 

SCS:aeh 04/08/05 245-68071-01 369305.doc

Applicants filed this Information Disclosure Statement ("IDS") before the mailing date of a first Office action on the merits. As a result, no fee should be required to file this IDS.

However, if the Patent Office determines that a fee is required for Applicants to file this IDS, please charge any such fees, or credit overpayment, to Deposit Account No. 02-4550. A duplicate copy of this Information Disclosure Statement is enclosed.

The filing of this IDS shall not be construed to be an admission that the information cited in the statement is, or is considered to be, prior art or otherwise material to patentability as defined in 37 C.F.R. §1.56.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

Stacey C. State

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Attorney Docket Number	245-68071-01
Application Number	10/803,502
Filing Date	March 17, 2004
First Named Inventor	Paul
Art Unit	3729
Examiner Name	Unknown

## **U.S. PATENT DOCUMENTS**

NOTE: If this application was filed after June 30, 2003, copies of United States patents and United States published patent applications do not have to be provided to the Patent Office. This requirement of 37 C.F.R. § 1.98(a)(2)(i) has been waived by the United States Patent and Trademark Office pursuant to the Official Gazette Notice on August 5, 2003 (1276 OG 55).

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		4,647,748	3/1987	Glassman
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EXAMINER	DATE
SIGNATURE:	CONSIDERED:
SIGNATURE.	CONSIDERED:

<sup>\*</sup> Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.

				Attorney Docket Number 245-68071-01 Application Number 10/803,502		<u> </u>
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			Filing Date		March 17, 2004	
				ed Inventor	Paul	
				Art Unit	iod III voiitoi	3729
				Examiner	Name	Unknown
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BY APPLICANT	First Named Inventor	Paul	
	Art Unit	3729	
	Examiner Name	Unknown	
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